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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8585**  
Takashi OHSAKO et al. : Attorney Docket No. 2003\_1364A  
Serial No. 10/677,221 : Group Art Unit 2823  
Filed October 3, 2003 : Examiner Joannie Garcia  
METHOD OF MANUFACTURING : **Mail Stop: AF**  
SEMICONDUCTOR ELEMENT

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**AMENDMENT AFTER FINAL**

Please  
Enter Commissioner for Patents  
/J.G./ P.O. Box 1450  
02/05/2008 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated October 30, 2007, please amend the  
above-identified application as follows.

**RESPONSE UNDER 37.CFR1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2823**

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975